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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2871
Serial No. : 09/517,354 Examiner : Kenneth Parker
Filed : March 2, 2000
Title : METHOD OF MANUFACTURING A DISPLAY DEVICE HAVING A DRIVER
CIRCUIT ATTACHED TO A DISPLAY SUBSTRATE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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INFORMATION DISCLOSURE STATEMENT

OFFICE OF PETITIONS

Applicant submits the references listed on the attached form PTO-1449.

With respect to JP 46-019008, no English Translation is available for this Japanese patent. This patent claims priority to U.S. Application Serial No. 636,928, filed May 8, 1967. The Japanese Patent Office asserts that this reference is relevant to the use of various etching gases such as CIF, BrF_n, and IF_n. Claim 1 of this patent teaches the use of a gas mixture including hydrogen and a gas of CIF, CIF₃, BrF, BrF₃, BrF₅, IF₅ or IF₇ for etching Si or Ge.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 11/18/03


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